

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of | : | |
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| Yoshiharu OHTA et al. | : | Confirmation No. 3366 |
| | : | |
| U.S. Patent Application No. 10/594,636 | : | Group Art Unit: 1793 |
| | : | |
| Filed: September 28, 2006 | : | Examiner: Michael A. MARCHESCHI |

For: SEMICONDUCTOR POLISHING COMPOSITION

EXPRESS ABANDONMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

I request that the above-identified application be expressly abandoned, without prejudice or disclaimer, as of the filing date of this paper.

I am an attorney of record. My attorney registration number is 45,943.

Applicants do not intend to request reconsideration of this matter without prejudice or disclaimer. No one should infer anything from Applicant's business decision not to continue prosecution in this matter.

Respectfully submitted,

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